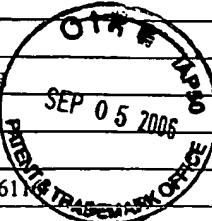


INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Multiple sheets used when necessary)</i>		Application No.	10/807,147
		Filing Date	March 24, 2004
		First Named Inventor	Tsai, Hsiung-Kuang
		Art Unit	2873
SHEET 1 OF 3		Examiner	Lester, E.
		Attorney Docket No.	QCO.090A/IDC- 061



U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	1	4,074,480	02-21-1978	Burton	
	2	4,956,619	09-11-1990	Hornbeck	
	3	5,018,256	05-28-1991	Hornbeck	
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	6	5,244,707	09-14-1993	Shores	
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	24	2002-0075551	06-20-2002	Daneman	
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Examiner Signature	/Evelyn Lester/	Date Considered	12/29/2006
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		Art Unit	2873
(Multiple sheets used when necessary)		Examiner	Lester, E.
SHEET 2 OF 3		Attorney Docket No.	QCO.090A/IDC- 06116

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
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EAL	44	WO 02/042716	05/30/2002	Microsensors	
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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ¹
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(Multiple sheets used when necessary)		Examiner	Lester, E.
SHEET 3 OF 3		Attorney Docket No.	QCO.090A/IDC- 06116

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
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